

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/905,320
Filing Date July 13, 2001
Inventor Cem Basceri et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Eric B. Fuller
Attorney's Docket No. MI22-1657
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium
Titanate Comprising Dielectric Layers, Including Such Layers Having a
Varied Concentration of Barium and Strontium Within the Layer

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TC 1700

RESPONSE TO FEBRUARY 13, 2003 OFFICE ACTION

To: Commissioner for Patents
Washington, D.C. 20231

VIA EXPRESS MAIL

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 West First Avenue, Suite 1300
Spokane, WA 99201-3828

Responsive to the Office Action dated February 13, 2003, Applicant
amends and remarks as follows:

AMENDMENTS